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SERIAL NUMBER 10/822,208	FILING DATE 04/08/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. MI22-2519
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APPLICANTS

Eric R. Blomiley, Boise, ID;
 Nirmal Ramaswamy, Boise, ID;
 Ross S. Dando, Nampa, ID; Joel A. Drewes, Boise, ID;
 Alan B. Colwell, Boise, ID;
 Eduardo A. Tovar, Caldwell, ID;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 06/22/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY ID	SHEETS DRAWING 12	TOTAL CLAIMS 49	INDEPENDENT CLAIMS 6
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ADDRESS
 021567
 WELLS ST. JOHN P.S.
 601 W. FIRST AVENUE, SUITE 1300
 SPOKANE , WA
 99201

TITLE
 Deposition apparatuses, methods of assessing the temperature of semiconductor wafer substrates within deposition apparatuses, and methods for deposition of epitaxial semiconductive material

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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